



Docket: P910218

THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Chin-Cheng Yang

Serial No.: 10/668,698

Filed: September 23, 2003

For: METHODS FOR FORMING A
PHOTORESIST PATTERN USING AN
ANTI-OPTICAL PROXIMITY EFFECT

Examiner: Le Dung Anh

Group Art 2818

Unit:

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

I hereby certify that this correspondence is being deposited with the United States Postal Service, First Class mail, postage prepaid, in an envelope addressed to Mail Stop Non-Fee Amendment, Commissioner of Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on November 10 2004.
STOUT, UXA, BUYAN & MULLINS, LLP

Kenton R. Mullins, Reg. No. 36,331

AMENDMENT

Dear Sir:

This is in response to the August 24, 2004 Office Action issued by the United States Patent and Trademark Office regarding the above-identified application. A response to the Office Action is due three months, excluding weekends and federal holidays, from the mailing date thereof. Accordingly, this Amendment is being timely filed. Please amend the subject application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks begin on page 9 of this paper.